10th EUV-FEL Workshop



Report of Contributions

Contribution ID: 1 Type: not specified

Openning Remarks

Wednesday, 28 January 2026 13:10 (10 minutes)

Presenter: SUNAO ISHIHARA (REPRESENTATIVE OF EUV-FEL LIGHT SOURCE STUDY GROUP FOR INDUSTRIALIZATION) 13:10-13:20

Greeting

Contribution ID: 2 Type: not specified

Greeting

Wednesday, 28 January 2026 13:20 (5 minutes)

Presenter: AKIRA HENDA (MEXT)

Contribution ID: 3 Type: not specified

Target of the workshop

Wednesday, 28 January 2026 13:25 (10 minutes)

Presenter: HIROSHI KAWATA (SECRETARY OF THE WORKSHOP, KEK)

Contribution ID: 4 Type: **not specified**

[Key-note Lecture] Development of Next-Generation Semiconductor Process, Technologies for EUV and BEUV under Japan's "K Program" by JST

Wednesday, 28 January 2026 13:35 (40 minutes)

Presenter: JUNJI YUMOTO (THE UNIVERSITY OF TOKYO)

Contribution ID: 6 Type: not specified

[Invited Talk] The Vast Light Source

Wednesday, 28 January 2026 15:25 (40 minutes)

Presenter: YOSUKE HONDA (ACCELERATOR LABORATORY, KEK)

Contribution ID: 7 Type: **not specified**

[Invited Talk] Development of Multilayer Mirrors for BEUV Reflective Optics -Current Status of an Ongoing Project-

Wednesday, 28 January 2026 16:05 (40 minutes)

Presenter: TAKEO EJIMA (TOHOKU UNIVERSITY)

Contribution ID: 8 Type: not specified

Closing address

Wednesday, 28 January 2026 16:45 (5 minutes)

Presenter: SHINICHI ADACHI (EXECUTIVE DIRECTOR, KEK)

Contribution ID: 9 Type: not specified

Photo-session

Wednesday, 28 January 2026 16:50 (5 minutes)

Contribution ID: 10 Type: not specified

[Key-note Lecture] TBA

Presenter: NICHOLAS KELEZ (XLIGHT INC., CEO & CTO)

Contribution ID: 11 Type: not specified

[Key-note Lecture] Reviving Moore's Law with an EUV FEL

Presenter: NICHOLAS KELEZ (XLIGHT INC., CEO & CTO)

Contribution ID: 12 Type: not specified

[Key-note Lecture] Reviving Moore's Law with an EUV FEL

Wednesday, 28 January 2026 14:15 (40 minutes)

Presenter: NICHOLAS KELEZ (XLIGHT INC., CEO & CTO)